## Notice of References Cited Application/Control No. 10/657,557 Applicant(s)/Patent Under Reexamination TAKEYAMA, TOSHIHISA Examiner LENA NAJARIAN Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2002/0004727	01-2002	Knaus et al.	705/3
*	В	US-2002/0010679	01-2002	Felsher, David Paul	705/51
*	C	US-6,345,268	02-2002	de la Huerga, Carlos	707/3
*	D	US-2004/0034550 A1	02-2004	Menschik et al.	705/3
*	Е	US-2002/0016718	02-2002	Rothschild et al.	705/2
*	F	US-2001/0041991	11-2001	Segal et al.	705/3
	G	US-			
	Ι	US-			
	-	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	C					
	V					
	w					
	х					

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